EXPEDITED PROCEDURE EXAMINING GROUP

Attorney Docket No. 401308

In re Application of: Application No.

Takahiro OHNAKADO

09/911,581

July 25, 2001

SI-MOS HIGH-EREQUENCY SEMICONDUCTOR DEVICE

Mail Stop AF

Filed: For:

Sir:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

NOV 0 3 2003

Corres. and Mail

Small entity status is claimed for this application under 37 CFR 1.27.

Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.

Other:

Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

2					SMALL ENTITY		OTHER THAN A SMALL ENTITY		
TIME EXTENSION PETITION FEE			none		\$ 0.00		\$ 0.00		
H-** - 8	subtract time extension none fee previously paid		none	one		(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST Number Previously Paid For	EXTRA CLAIMS PRESENT	RATE	ADDIT. CLAIM FEE	RATE	Addit. Claim Fee	
TOTAL		Minus		=0	x 9=	\$	x 18=	\$	
INDEPENDENT		Minus		=0	x 43=	\$	x 86=	\$	
FIRST PRESENTATION OF MULTIPLE CLAIM					+ 145=	\$	+ 290=	\$	
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$	

Mathematical The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.

Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

Any patent application processing fees under 37 CFR 1.17.

espectfully submitted,

Wyan∕ol, Reg∕ No VOIT/S MAYER

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(202) 737-6776 (facsimile)

(ECHNOLOGY CENTER 2800

Amendment or ROA Transmittal (Revised 10/2/03)



RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2815

PATENT Attorney Docket No. 401308

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takahiro OHNAKADO

Application No. 09/911,581

Art Unit: 2815

Examiner: N Drew Richards

Filed: July 25, 2001

For: SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE

RESPONSE TO OFFICE ACTION

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 4, 2003, please enter the following amendments and consider the following remarks.

